

<b>Notice of References Cited</b>	Application/Control No. 10/824,482	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
	Examiner Richard L. Schilling	Art Unit 1752	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-3,697,275	10-1972	Hayakawa et al.	430/270.1
*	C	US-3,782,944	01-1974	Hayakawa et al.	430/325
*	D	US-4,547,450	10-1985	Maeda et al.	430/202
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	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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